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## BIB DATA SHEET

CONFIRMATION NO. 8435

<b>SERIAL NUMBER</b> 08/893,917	<b>FILING or 371(c) DATE</b> 07/11/1997 <b>RULE</b>	<b>CLASS</b> 216	<b>GROUP ART UNIT</b> 1716	<b>ATTORNEY DOCKET NO.</b> AM2119/T2130	
<b>APPLICANTS</b> KARL A. LITTAU, PALO ALTO, CA; CHILIANG L. CHEN, CUPERTINO, CA; ANAND VASUDEV, MENLO PARK, CA; <b>** CONTINUING DATA *****</b> <b>** FOREIGN APPLICATIONS *****</b> <b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 12/02/1997					
Foreign Priority claimed <input type="checkbox"/> Yes <input checked="" type="checkbox"/> No 35 USC 119(a-d) conditions met <input type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <u>/RUDY ZERVIGON/</u> Examiner's Signature		<input type="checkbox"/> Met after Allowance Initials	<b>STATE OR COUNTRY</b> CA	<b>SHEETS DRAWINGS</b> 14	<b>TOTAL CLAIMS</b> 5 <b>INDEPENDENT CLAIMS</b> 1
<b>ADDRESS</b> KILPATRICK TOWNSEND & STOCKTON LLP / AMAT TWO EMBARCADERO CENTER EIGHTH FLOOR SAN FRANCISCO, CA 94111-3834 UNITED STATES					
<b>TITLE</b> REMOTE PLASMA CLEANING SOURCE HAVING REDUCED REACTIVITY WITH A SUBSTRATE PROCESSING CHAMBER					
<b>FILING FEE RECEIVED</b> 1146	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		